

Electronic Patent Application Fee Transmittal

Application Number:	10751898
Filing Date:	07-Jan-2004
Title of Invention:	Plasma processing apparatus and focus ring
First Named Inventor/Applicant Name:	Shosuke Endoh
Filer:	Marvin Jay Spivak/LaKisha Durham
Attorney Docket Number:	247409US2

Filed as Large Entity

Utility Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Claims in excess of 20	1202	4	50	200
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Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 3 months with \$0 paid	1253	1	1050	1050
Miscellaneous:				
Total in USD (\$)				1250